

<b>Notice of References Cited</b>	Application/Control No. 10/650,574	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner James D. Stein	Art Unit 2874	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,571,041	05-2003	Bourcier et al.	385/52
*	C	US-6,668,128	12-2003	Hattori et al.	385/136
*	D	US-6,654,524	11-2003	Shekel et al.	385/52
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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